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## Graphical abstract

**Anodic formation of self-organized Ti(Nb,Sn) oxide nanotube arrays with tuneable aspect ratio and size distribution**

Electrochemistry Communications xxx (2013) xxx – xxx

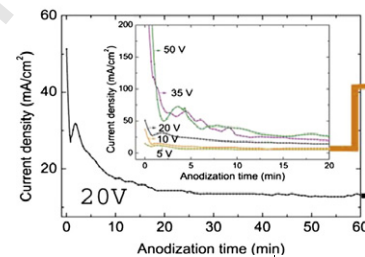
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## Electrochemistry Communications

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## Highlights

**Anodic formation of self-organized Ti(Nb,Sn) oxide nanotube arrays with tuneable aspect ratio and size distribution**

Electrochemistry Communications xxx (2013) xxx–xxx

J. Fornell <sup>a,\*</sup>, N.T.C. Oliveira <sup>b</sup>, E. Pellicer <sup>a</sup>, N. Van Steenberge <sup>c</sup>, M.D. Baró <sup>a</sup>, C. Bolfarini <sup>b</sup>, J. Sort <sup>d</sup><sup>a</sup> *Departament de Física, Universitat Autònoma de Barcelona, 08193 Bellaterra, Spain*<sup>b</sup> *Department of Materials Engineering – DEMa, Universidade Federal de São Carlos (UFSCar), 13565-905 São Carlos, SP, Brazil*<sup>c</sup> *OCAS N.V., Pres. J.F. Kennedylaan 3, BÈ-9060 Zelzate, Belgium*<sup>d</sup> *Institució Catalana de Recerca i Estudis Avançats and Departament de Física, Universitat Autònoma de Barcelona, 08193 Bellaterra, Spain*

- One-step anodization is used to prepare self-organized Ti(Nb,Sn) oxide nanotubes.
- Tunable nanoscale geometries can be achieved by varying the anodization conditions.
- The length and the diameter of the NTs tend to increase with the applied voltage.
- Combining TiO<sub>2</sub> with NbO<sub>2</sub> and SnO<sub>2</sub> might provide additional functionalities.

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## Electrochemistry Communications

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## Short communication

## Anodic formation of self-organized Ti(Nb,Sn) oxide nanotube arrays with tuneable aspect ratio and size distribution

J. Fornell<sup>a,\*</sup>, N.T.C. Oliveira<sup>b</sup>, E. Pellicer<sup>a</sup>, N. Van Steenberge<sup>c</sup>, M.D. Baró<sup>a</sup>, C. Bolfarini<sup>b</sup>, J. Sort<sup>d</sup><sup>a</sup> Departament de Física, Universitat Autònoma de Barcelona, 08193 Bellaterra, Spain<sup>b</sup> Department of Materials Engineering – DEMA, Universidade Federal de São Carlos (UFSCar), 13565-905 São Carlos, SP, Brazil<sup>c</sup> OCAS N.V., Pres. J.F. Kennedylaan 3, BE-9060 Zelzate, Belgium<sup>d</sup> Institutió Catalana de Recerca i Estudis Avançats and Departament de Física, Universitat Autònoma de Barcelona, 08193 Bellaterra, Spain

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## ABSTRACT

In the present communication one-step anodization is used to prepare large arrays of self-assembled Ti(Nb,Sn) oxide nanotubes on Ti–Nb–Sn alloy. Tuneable nanoscale geometries (unimodal vs. bimodal size distribution with variable length/diameter ratios) can be controllably achieved by varying the anodization conditions, which are highly desirable for enhanced functionalities in widespread applications.

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## 1. Introduction

Bulk TiO<sub>2</sub> is a non-toxic, environmentally friendly and corrosion resistant material. The key functional features are mainly given by its exceptional biocompatibility and the almost unique ionic and electronic properties of this oxide. TiO<sub>2</sub> is a wide band gap semiconductor ( $E_g \approx 3$  eV) with suitable band-edge positions that enable its use in solar cells, photocatalysis, electrochromic applications, biomedical coatings, sensors or smart-surface coatings [1]. To improve TiO<sub>2</sub> properties, investigations in this field have been directed towards the development of 1D TiO<sub>2</sub> nanostructures with the aim of increasing the specific surface area (which is crucial for any catalytic reaction) as well as modulating its electronics [1]. Hitherto, the introduction of secondary electronically active species into the lattice of nanostructured TiO<sub>2</sub> has been pursued in order to broaden its range of applications. Among them, niobium and tin species emerge as suitable candidates to dope TiO<sub>2</sub> in order to boost its physicochemical properties.

In the present work, the feasibility of fabricating self-organized nanotubes (NTs) by anodization on Ti–21Nb–11Sn (wt.%) alloy is investigated. Applied voltages have been varied between 5 and 50 V, whereas anodization time has been kept at 1 h. The growth parameters that lead to NTs with controlled diameters and thickness are discussed. It is interesting to mention that the composition of the alloy anodized in this study could possibly provide a material with good biocompatibility, high strength and low Young's modulus, thus

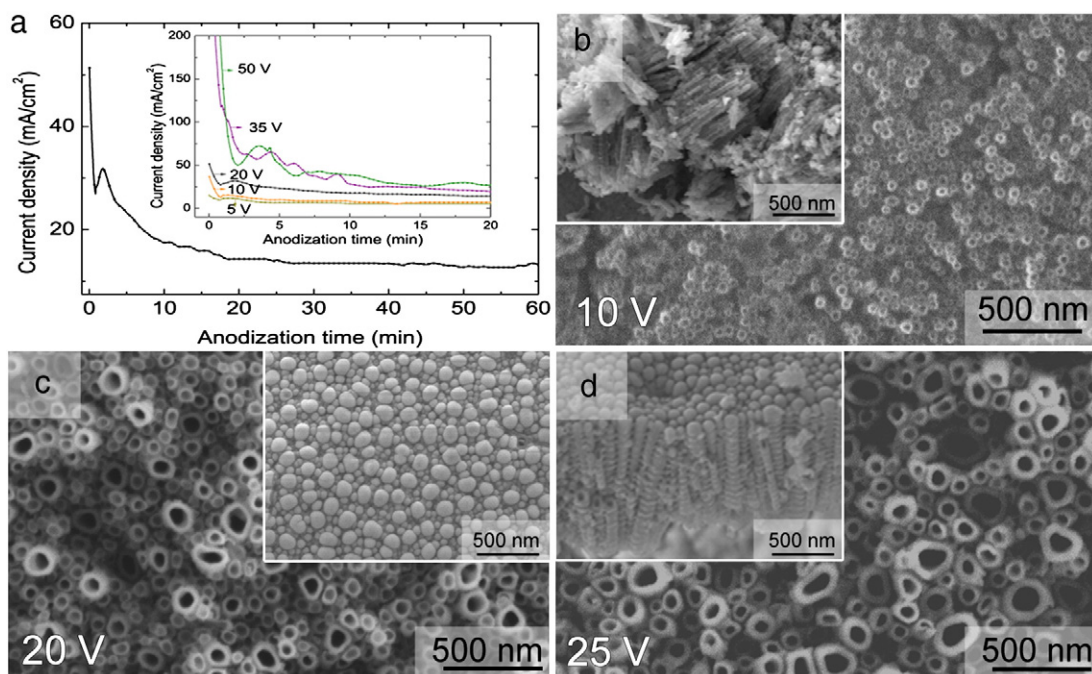
minimizing the so-called stress shielding effects [2]. Moreover, since Sn and Nb are less expensive than Ti, the base Ti–Nb–Sn material is inherently less costly than high-purity Ti. To the best of our knowledge, while the growth of an anodic oxide at the surface of Ti–Nb–Sn alloy has already been described [3], the formation of NT arrays has not yet been reported. Furthermore, bearing in mind the synergies achieved upon combining Nb<sub>2</sub>O<sub>5</sub> or SnO<sub>2</sub> with TiO<sub>2</sub> NTs, the here-synthesized Ti(Nb,Sn) oxide NTs on the Ti–Nb–Sn alloy will likely enhance the functionality of this material for a wide range of applications.

## 2. Experimental details

Rods of 4 mm of Ti–21Nb–11Sn alloy (wt.%) were prepared by levitation melting and subsequent injection into Cu mold. Self-organized nanotube oxide layers were grown by electrochemical anodization in 0.31 M NaF + ethylene glycol/water (50:50) electrolyte solution at voltages ranging from 5 to 50 V. Prior to anodization disks of 0.5 mm thick were cut from the rod and ground wet with 1200 grid SiC paper. After anodization, the samples were rinsed for 5 min with ethanol and distilled water in ultrasonic bath and dried at room temperature. To structurally characterize the as-anodized samples Scanning Electron Microscopy (SEM, Zeiss Merlin and Fei Inspect S50), and Transmission Electron Microscopy (TEM, JEOL-2011 200 kV) observations were carried out. X-ray photoelectron spectroscopy (XPS) analyses were conducted on a PHI equipment 5500 Multi Technique using the Al K $\alpha$  radiation (1486.6 eV).

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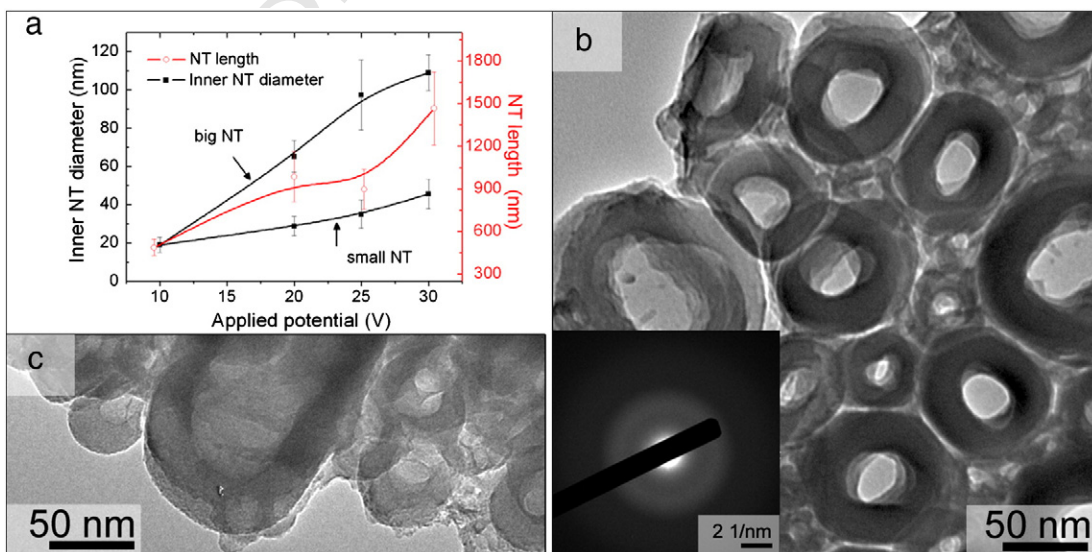
**Fig. 1.** (a) Current density–anodization time ( $j$ – $t$ ) curve for the Ti–21Nb–11Sn alloy anodized at 20 V (Inset:  $j$ – $t$  curve anodized at 5, 10, 20, 35 and 50 V). (b–d) top view SEM images of Ti–21Nb–11Sn alloy anodized at (b) 10 V, (c) 20 V and (d) 25 V. Insets in (b) and (d) show cross-section-views, while inset in (c) is a bottom view.

### 3. Results and discussion

Fig. 1a displays the current density–time ( $j$ – $t$ ) curve recorded during anodization at an applied voltage of 20 V. The curve shows the typical shape for a self-organization process; that is, after an initial exponential decay ascribed to the formation of a compact oxide layer, the current increases until it reaches a maximum value. At this point, the surface is locally activated and pores start growing randomly. Due to the pore growth, the active area increases also resulting in an increase in  $j$ . Hereafter, since the pores start interfering with each other, the current density decreases until it reaches a steady-state value (around 13 mA/cm<sup>2</sup>) and a self-ordered structure continues growing with time [1,4]. Inset of Fig. 1a displays the  $j$ – $t$  curves applied at 5, 10, 20, 35 and 50 V. From these curves, larger current decays are

observed as larger potentials are applied. As a result, thicker oxide layers grow at higher applied voltages resulting in larger NT. The curves recorded at 5 and 10 V reach the steady-state value much sooner (after 5 min of anodization) than the others suggesting that, under these conditions, a uniform and continuous nanotubular growth should take place. This observation is in agreement with SEM images of the sample produced at 10 V (Fig. 1b). When the applied voltage is 5 V, however, the nanotube morphology is not well-defined. On the other hand, for an applied voltage larger than 30 V, internal stresses result in NT detachment from the surface during the cleaning process following anodization.

Fig. 1b–d shows SEM images of the structures formed upon anodization of Ti–Nb–Sn alloy at 10, 20 and 25 V. After 1 h of anodization at 10 V, unimodal size distribution is observed (Fig. 1b) whereas



**Fig. 2.** (a) Dependence of diameter and nanotube length on applied potential, (b–c) TEM microphotographs of nanotubes formed on Ti–21Nb–11Sn alloy, (b) top view image (the inset shows corresponding SAED pattern), (c) cross-section image.

t1.1 **Table 1**  
 t1.2 Elemental composition of the nanotube oxide layer formed at an applied potential of  
 t1.3 20 V, determined by XPS, at three different penetration depths (after sputtering with  
 t1.4 Ar ions for 1, 30 and 60 min).

| Element (at.%)  |        | Ti   | Nb  | Sn  | O    | F   |
|-----------------|--------|------|-----|-----|------|-----|
| Sputtering time | 1 min  | 22.9 | 6.2 | 1.4 | 62.2 | 7.3 |
|                 | 30 min | 26.3 | 8.4 | 1.6 | 57.3 | 6.4 |
|                 | 60 min | 27.6 | 8.9 | 2   | 55.3 | 6.2 |

109 bimodal size distribution is detected at larger applied potentials  
 110 (Fig. 1c and d) where the big NTs are surrounded by the small ones.  
 111 This bimodal size distribution is even more evident from the bottom  
 112 view depicted in the inset of Fig. 1c. Here, arrangements consisting  
 113 of rounded grains of about 120 nm and 48 nm in diameter are seen.  
 114 The dependence of both the NT diameter and length against the anod-  
 115 ization potential is plotted in Fig. 2a. It is interesting to notice that  
 116 from the test carried out at 10 V, an approximately 500 nm-thick  
 117 layer of unimodal-sized NTs with a diameter around 20 nm is formed  
 118 (Fig. 1b). However, inner NT diameters as well as NT length tend to in-  
 119 crease with the applied voltage until reaching a 1.7  $\mu\text{m}$ -thick layer of  
 120 bimodal-sized NTs with diameter sizes around 110 nm and 40 nm  
 121 for the big and small NTs, respectively, when the applied potential is  
 122 30 V. At the intermediate applied potentials, self-organized NT layers  
 123 were formed consisting of arrays with two distinctly different tube  
 124 diameters, e.g. of about 67 nm and 30 nm for the alloy anodized at  
 125 20 V. Such bimodal size distribution may be attributed to two factors:  
 126 i) alloy composition (i.e., alloying elements (Nb and Sn) influence the  
 127 alloy's microstructure and consequently NT growth) and ii) geometry

128 stabilization effects under certain anodization conditions. On the  
 129 one hand,  $\text{Ti}_{21}\text{Nb}_{11}\text{Sn}$  is a two-phase material ( $\beta$  and  $\omega$  phases co-  
 130 exist) that can hinder the growth of uniformly sized NTs. On the other  
 131 hand, it has been reported that some binary  $\text{TiX}$  ( $X = \text{Nb}, \text{Zr}$ ) alloys  
 132 show self-organization on two-size scales [5,6], so that the growth  
 133 factor of the big diameter NTs typically corresponds to that of Ti  
 134 ( $f_{g,\text{TiO}_2} \approx 2.5 \text{ nm/V}$ ) while that of the small diameter NTs is smaller  
 135 and, as a consequence, they grow recessed. In our case,  $f_g$  would be  
 136 around 1.6 nm/V for the big NTs and 0.55 nm/V for the small ones.

137 Fig. 2 shows top view (Fig. 2b) and cross-section (Fig. 2c) TEM  
 138 images of the structures formed by anodization of the  $\text{Ti}_{21}\text{Nb}_{11}\text{Sn}$   
 139 alloy at 20 V. The TEM images confirm that hollow NT structures with  
 140 a bimodal size distribution are obtained. Namely, large-diameter NTs  
 141 with 23 nm-thick walls (big NT) can be observed along with NTs of  
 142 smaller diameter with 11 nm-thick walls (small NT). No significant dif-  
 143 ferences in composition were observed depending on the NT diameter,  
 144 at least within the accuracy of the EDX technique. From the Selected  
 145 Area Electron Diffraction (SAED) pattern (inset of Fig. 2b) the amorphous  
 146 character of the as-grown NTs is evidenced. In order to evaluate  
 147 the chemical composition along the tubes, XPS analyses were carried  
 148 out on the sample produced at an applied voltage of 20 V at three pen-  
 149 etration depths. i.e. after sputtering the NT layer with Ar ions for 1, 30  
 150 and 60 min. Assuming an etching rate of 5–10  $\text{nm min}^{-1}$ , this would  
 151 give a penetration of 5–10 nm, 150–300 nm and 300–600 nm, respec-  
 152 tively [7]. In all cases, the survey spectra indicate the presence of Ti,  
 153 Nb, Sn, O and F elements, the latter coming from the electrolyte. Quantita-  
 154 tive evaluation of the results is shown in Table 1. After sputtering  
 155 for 60 min an increase of the content of valve elements is detected  
 156 while the O content slightly decreases, as the measurement is likely

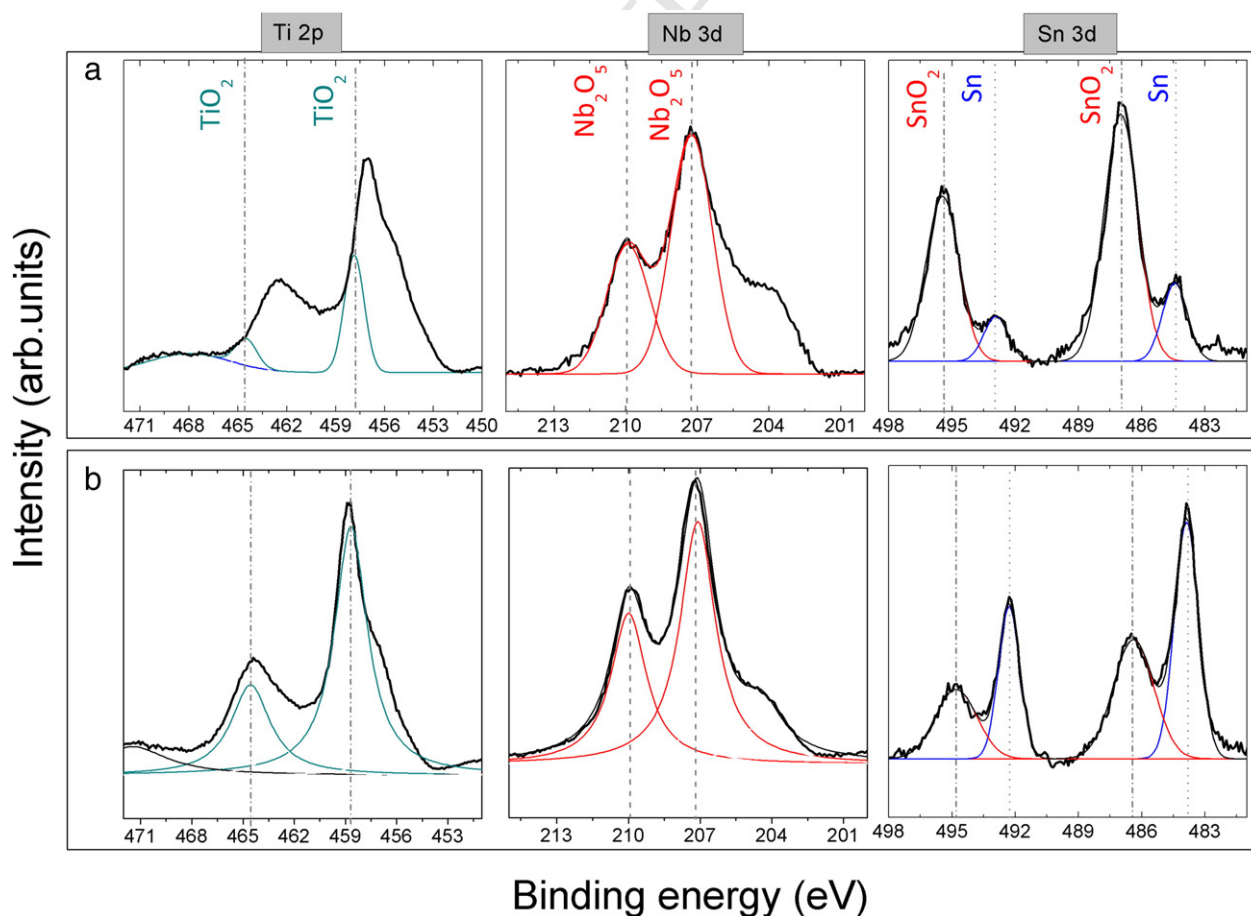
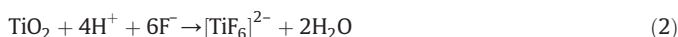
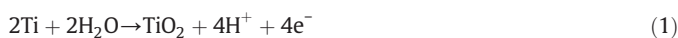


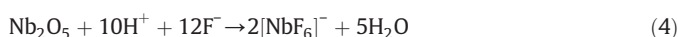
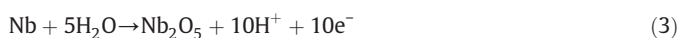
Fig. 3. Ti 2p, Nb 3d and Sn 3d core-level XPS spectra of the nanotube oxide layer formed at an anodizing voltage of 20 V after sputtering with Ar ions for (a) 1 min and (b) 1 min after air-annealing at 923 K for 60 min.

performed near the substrate. Ti (arising from TiO<sub>2</sub>) is the most abundant element, in agreement with the bulk alloy composition. A detail of the Ti 2p, Nb 3d and Sn 3d regions at t = 1 min is shown in Fig. 3. Multipeak fitting was carried out assuming a Gaussian distribution. The peaks located at 464.6 eV (Ti 2p<sub>1/2</sub>) and 458.7 eV (Ti 2p<sub>3/2</sub>) are associated with Ti<sup>4+</sup> valence state [8–10]. Discrepancies between the experimental data and the fitting are probably attributed to the existence of oxygen vacancies. The binding energies of 210.0 eV (Nb 3d<sub>5/2</sub>) and 207.2 eV (Nb 3d<sub>3/2</sub>) belong to Nb<sup>5+</sup> [11,12]. Deeper inside (t = 60 min), the zero-valent state of Nb emerges and a decrease of the peaks related to Nb<sub>2</sub>O<sub>5</sub> is observed (not shown). Likewise, in the case of Sn, the main peaks at 486.9 eV and 495.4 eV match the Sn<sup>2+</sup> valence state [11], whereas deeper inside of the nanotubes the main contribution comes from zero-valent state of Sn.

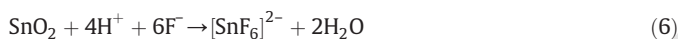
According to the XPS data, the formation of the composite NTs would mainly proceed via the following reactions:



for Ti;



for Nb;



for Sn.

According to several authors TiO<sub>2</sub> anatase could be obtained from the amorphous oxides directly by thermal annealing in air [13,14]. It is interesting to note that TiO<sub>2</sub> anatase nanotubes are believed to possess the highest biocompatibility among other titanium oxides and phases [15]. In our case, after annealing at 923 K for 60 min, α and β-Ti phases (arising from the substrate) and anatase and rutile phases coming from TiO<sub>2</sub> were identified. Detailed XPS analyses of the NT layer indicate that the main compounds resulting from the annealing process are TiO<sub>2</sub>, Nb<sub>2</sub>O<sub>5</sub> and SnO<sub>2</sub> (Fig. 3c). Niobium and tin oxide films have been previously evaluated in terms of cell growth and wettability with good results [16,17].

## 4. Conclusions

In summary, the formation of large arrays of self-ordered titanium–niobium–tin mixed oxide nanotubes by a simple step electrochemical self-assembly process is reported. By varying the applied voltage during anodization, the size distribution of the NTs evolves from unimodal to bimodal. Both the length and the inner diameter of the NTs tend to progressively increase with the applied voltage. The precise control of the alloy surface morphology (i.e., NT arrangement geometry) may facilitate and enhance the use of this material in widespread technological applications, including biomedical, photocatalysis, opto-electronic and electrochromic devices or sensors.

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